

Zurich University



## Design and Optimization of OLED Lightoutcoupling Enhancement Structures

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## Who we are

Zurich University of Applied Sciences







Anniversary 2004 - 2014 Research on OLED and OPV

AEVIOM

Sunfl

**WIM<sup>3</sup>OLED** 

**Wer** 



Software

swiss made software

## Our Customer's Pain

- Which problem do we solve?
  - Cumbersome and costly trial-and-error optimization
  - O Unlimited material and device configurations
  - Monitor/control quality
  - $\odot$  Understanding of operating mechanisms
- Our solution:

Virtual experiments on a PC with easy-to-use **software** and all-in-one measurement **hardware**!



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Clean room at Fraunhofer Institute IMPS, Dresden





100 individual OLEDs by T. Beierlein, IBM Zurich



## All-in-One!



#### Capacitance-Voltage



#### Dark Injection Transients





**paios** 2.0

characterization of solar cells

0.2

Cell Voltage

**IV-Curves** 

-34.38 -

The revolutionary platform for all-in-one

Light intest

0.8

Light inte=25.0 %

Light inte=50.0 %

Light inte=75.0 %

Light inte=100 %



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#### Photo-CELIV





5

## **Worldwide partners & customers**



ISSOFT

CYBERNET

HTTR

#### Key customers:

Novaled, BASF, Merck, Holst Centre, Fraunhofer, Dupont Displays, Samsung Display/SAIT, LG Display, LG Chem

Fluxim AG

semimetrics

Wavela

## **OLED Light Outcoupling Challenge**





- Direct Emission (only ~20%!)
- Guided Modes inside the organic layers (~20%)
- Substrate Guided Modes (~25%)
- Evanescent modes (not capable of propagation, e.g. surface plasmons at metallic electrodes) (~25%)

Most of the internally emitted light is trapped inside the OLED! Extra outcoupling tricks are needed to get more than 20% of the light!





Random scattering layer + HRI planarization ETRI, SID 2014

- External light outcoupling (ELO) structures:
  - · layers with scattering particles
  - microlense arrays
- High-index substrates
- Internal light outcoupling (ILO) structures:
  - nanostructures, textured interfaces & planarization layers
- → Simulation method must cope with such complex structures!
- → We may need to combine several outcoupling tricks for record efficiency.

## Design Challenges for Scattering OLEDs FLUXiM

- Scattering properties?
- What is the ideal haze? (def. as ratio of scattered light)
- How broad should scattering be?

- OLED stack properties?
- Should the OLED be highly reflective?
- How about absorption in OLED layers?



## **Impact of Haze on Emitted Power**



#### How strong should scattering be? (amount of haze?)



- The emitted power in air increases with the Haze.
- Even with 50% haze the emitted power almost doubles!

## Impact of Haze on the Emitted Spectrum

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\_UXiM



→ In order to achieve the target color, the OLED stack must be adjusted.



## How strong should angular light scattering be? FLUXiM



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- A maximum out-coupling efficiency is achieved for a Phong factor l > 1
- Too broad scattering functions (l <1) seem to have a negative impact on the outcoupling efficiency of the OLED.

## **Particle Scattering Films for OLEDs**



#### **Concentration dependence**

#### Angular emission

0.3 0.2

0.1

450

500

Wavelength [nm]

Without particles



#### Simulations with SETFOS 4.1

250





#### (Arbitrary Layer Sequences)

### Example: Thickness variation of green color filter



Hybrid model tackles thin & thick layers! e.g. encapsulation layers



# Summary of Simulation Workflow (OLED)



Bi-directional Scattering Function (BSDF)



**FLUXiM** 

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## **Measuring Scattering Properties**



Angular transmission vs. incidence angle (BTDF)





## **OLED Challenges**

Efficiency Lifetime Upscaling

Optimize EQE, Color...



#### Monitor & understand



C(f) for fresh & aged OLED

#### Design panels/displays, Minimize losses



Simulated potential with metal grid & shunts

## Large-area Electrode Simulations



## Reference OLED



(a) 0 metal stripes, 0 shunts simulation: bottom layer voltage distribution



(b) 0 metal stripes, 0 shunts simulation: top layer voltage distrbution

 OLED with horizontal metal grids and random shorts



(e) 8 metal stripes, 6 shunts simulation: bottom layer voltage distribution

![](_page_17_Picture_10.jpeg)

(f) 8 metal stripes, 6 shunts simulation: top layer voltage distribution

## Conclusions

![](_page_18_Picture_1.jpeg)

- We develop leading-edge simulation and characterization technology for large area (organic) electronics
- Mostly optical, electrical and thermal processes are investigated
- This technology accelerates R&D!

![](_page_18_Picture_5.jpeg)

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![](_page_19_Picture_6.jpeg)

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![](_page_19_Picture_8.jpeg)

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